CIVA ET Training

CIVA 2015 Training – ET



서울시 강남구 학동로 101길 26, 308호

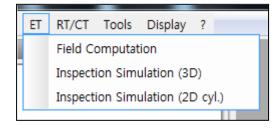
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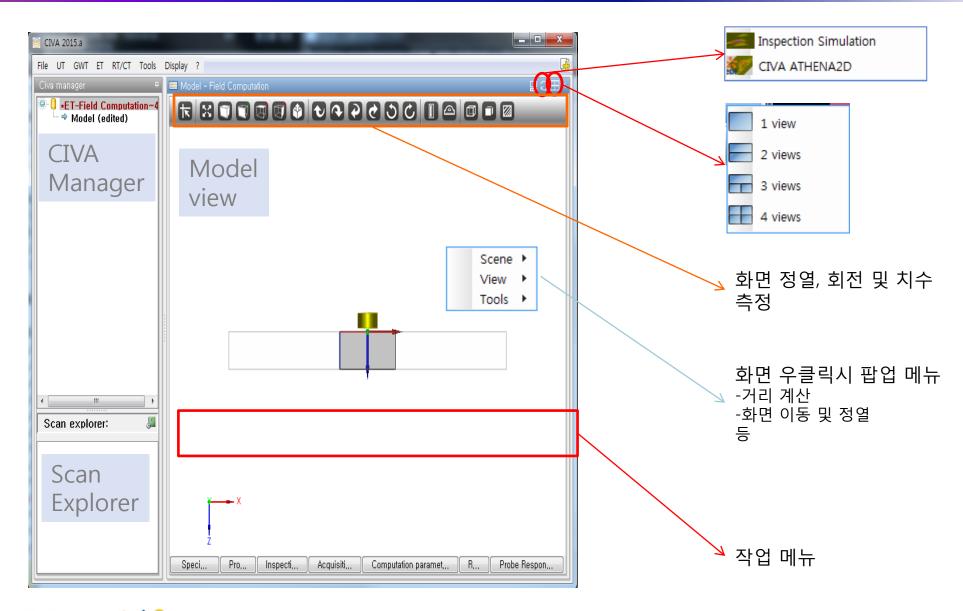
♦ET – main menu

- Field Computation : 탐침으로 부터 생성되는 자계 값 계산
- Inspection Simulation(3D): 3차원 형상의 결함으로 부터의 탐상 계산
- Inspection Simulation(2D cyl.) : 축대칭 형상에서의 결함의 ET 계산



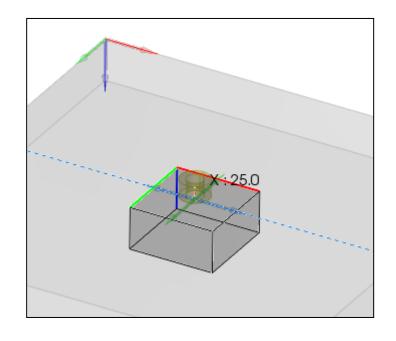


♦MENU 및 화면 안내





❖마우스 이용 방법



-화면에서의 마우스는

1. 좌 클릭: 화면 이동

2. 우 클릭 : 화면 확대(아래), 축소(위)

3. 휠 버튼 클릭: 회전

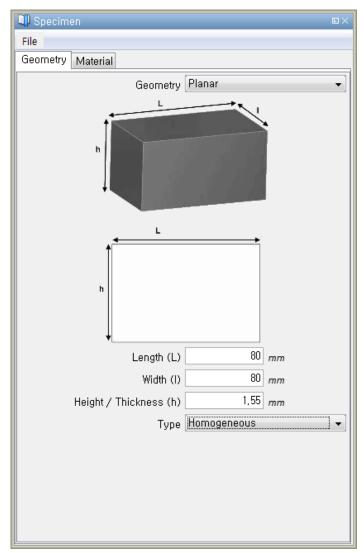
-Probe 및 Specimen 선택

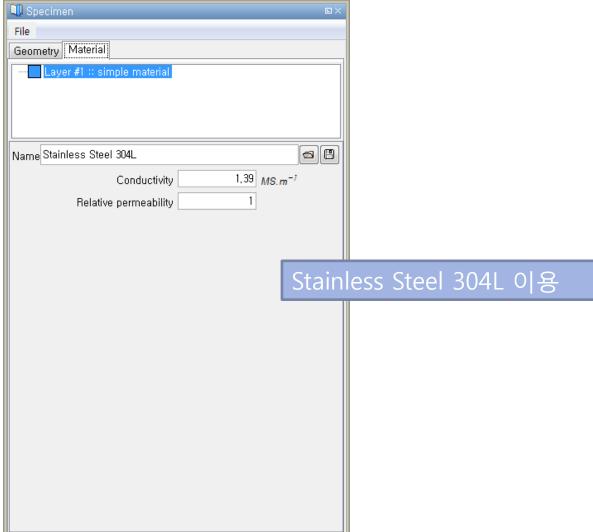
Probe 및 Specimen을 마우스 좌버튼 더블 클릭시 활성화 되며 동시에 x,y,z 축의 화살표가 생성이 됩니다.

생성된 화살표를 이용하여 각 축을 따라 이동 시킬 수 있습니다.

이러한 방법으로 화면에 표현되는 형태의 위치를 변경할 수 있습니다.

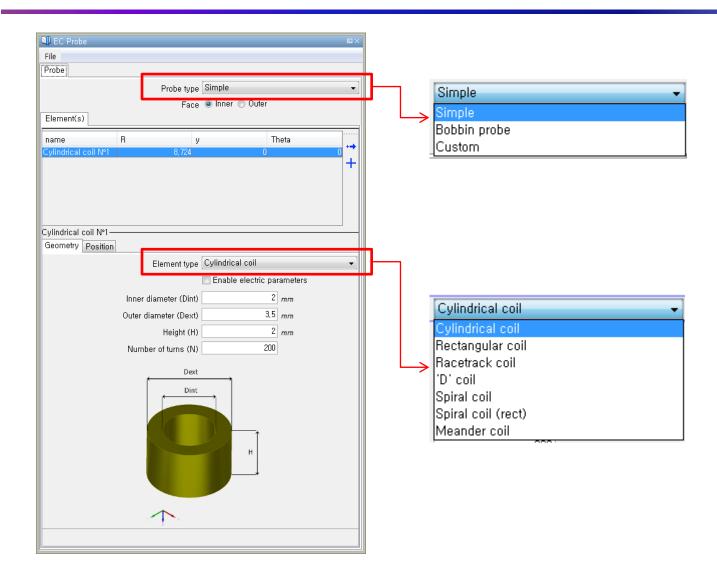
❖Specimen 설정





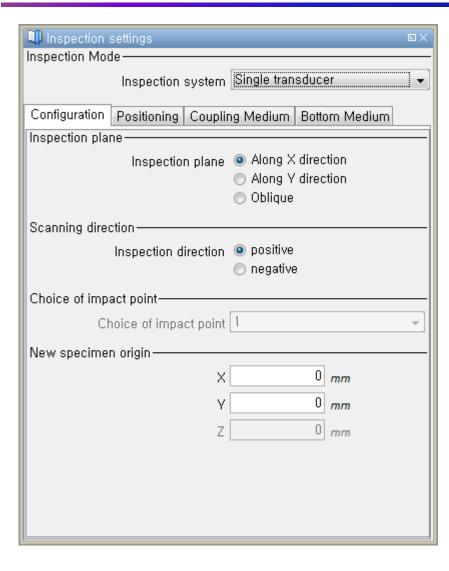


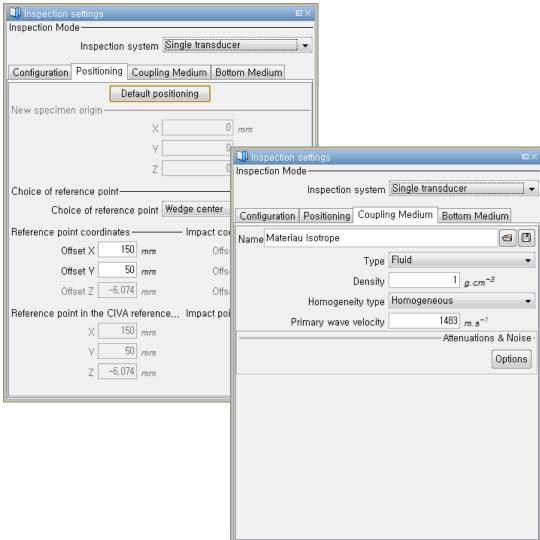






❖Inspection settings







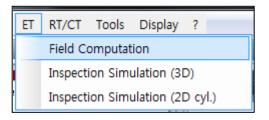
❖Example 1 – Flat component inspection

- Flat component inspection
- 1.1 Impedance diagram calculation

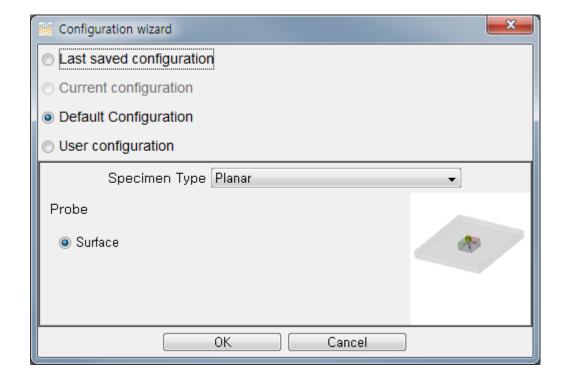




Field computation 실행

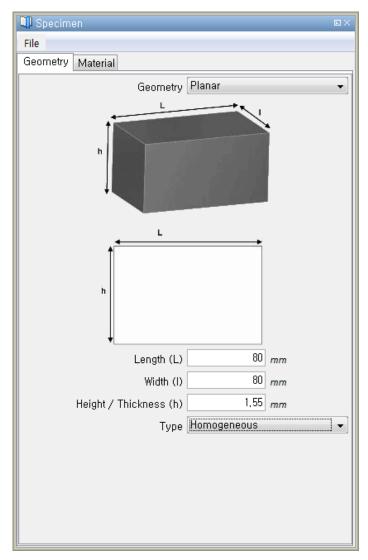


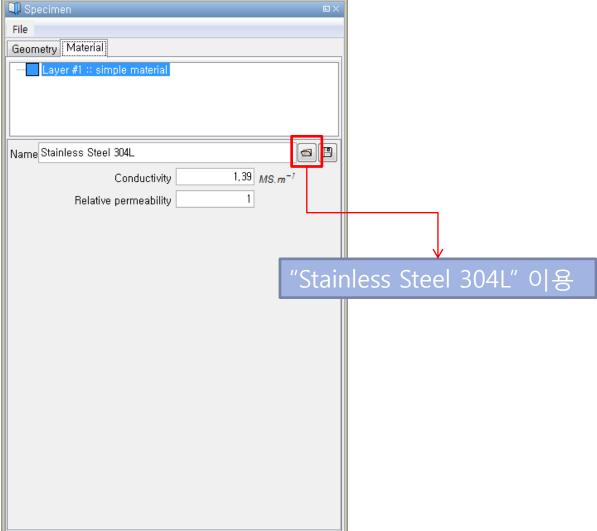
Configuration wizard





❖Specimen 설정

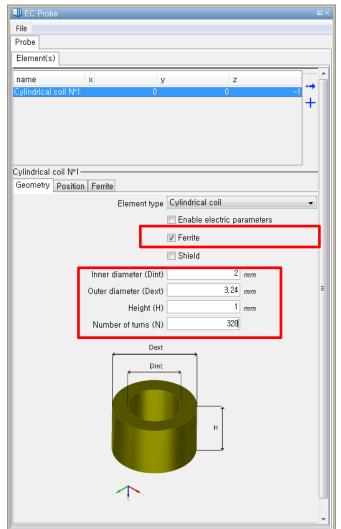


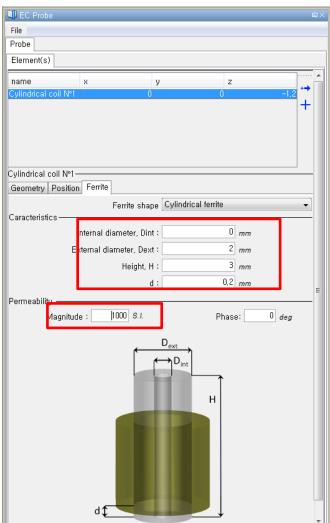


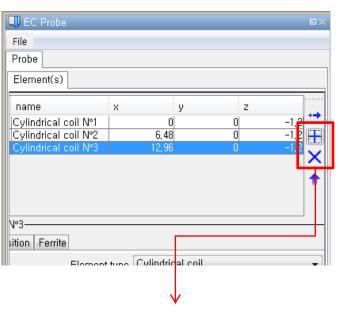


❖Probe 생성(1/2)

■ Probe 생성



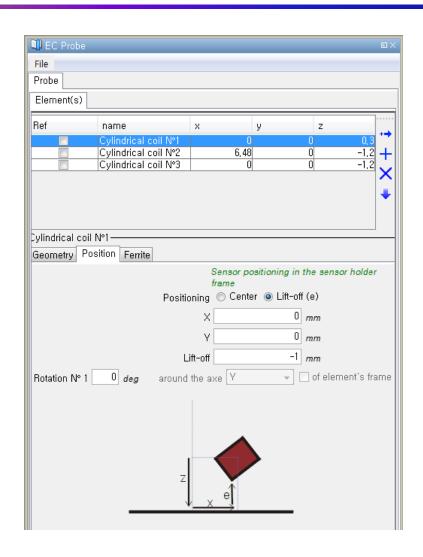




Element 추가 및 삭제 (2개 추가로 생성)



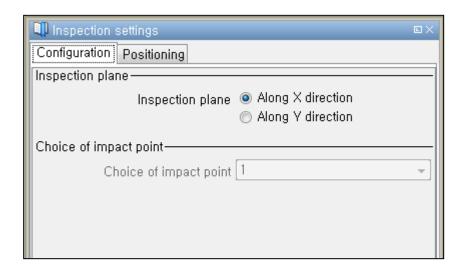
❖Probe 생성(2/2)

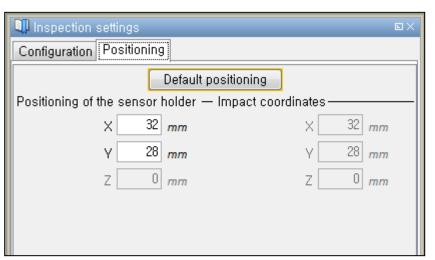


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Cylindrical coil Nº1 Geometry Position Ferrite				
decinety resident reinte		0	h -ld f	
		Sensor positioning in the sensor holder frame © Center © Lift-off (e)		
	·	0		
	×		mm	
	Υ	0	mm	
	Lift-off	0,3	mm	
Rotation N° 1 0 deg	around the	axe Y	of element's frame	
Cylindrical coil N°2—————				
Geometry Position Ferrite				
		Sensor positioning in the sensor holder frame		
	Positioning	Center Lift-off (e)		
	X	-2	mm	
	Υ	4	mm	
	Lift-off	[0,3]	mm	
Rotation N° 1 0 deg	around the	axe Y	of element's frame	
Cylindrical coil N°3				
Geometry Position Ferrite				
		Gensor positioning in the sensor holder frame		
	Positioning	○ Center ⊚ Lift-off (e)		
	X	2	mm	
	Υ	4	mm	
	Lift-off	0,3	mm	
Rotation N° 1 0 deg	around the	axe Y =	of element's frame	



❖Inspection 설정





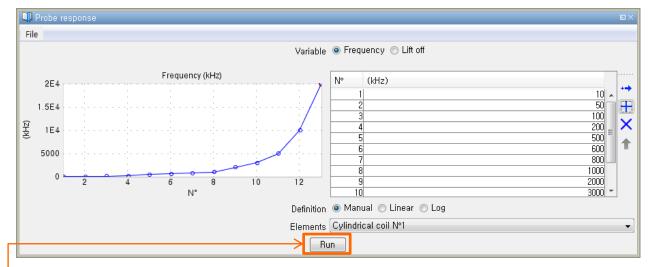


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❖Probe response 계산



- 우측 하단의 Probe Response 클릭



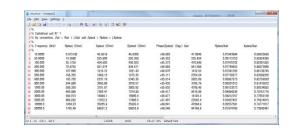
- 우측 + 클 클릭하여 항목을 늘려 1~14까지 10kHz~2000kHZ까지 입력합니다.

No	kHz	No	kHz
1	10	8	800
2	50	9	1000
3	100	10	2000
4	200	11	3000
5	300	12	5000
6	500	13	10000
7	600	14	20000

우측의 14개의 주파수를 입력하고 4번 400kHz를 선택한 후 RUN을 클릭하여 계산 진행



- Txt export를 통하여 계산 결과 확인(임피던스 계산)





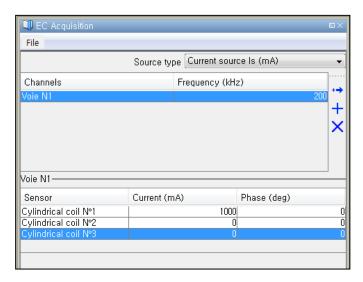
Flat component inspection1.2 Field computation



❖Acquisition 선정

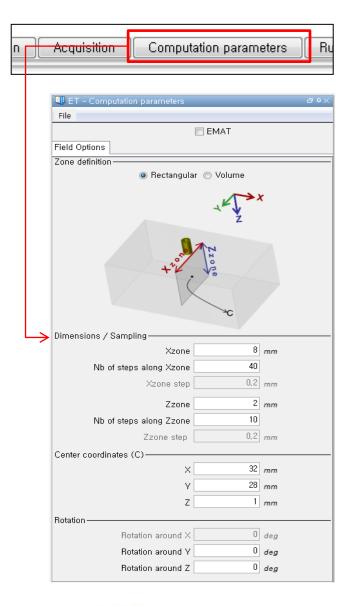


🃭 - 우측 하단에 Acquisition, Computation parameters의 계산 영역 지원



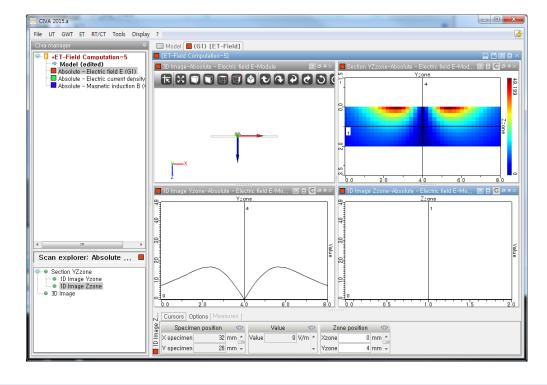


❖Computation parameters설정 및 Analysis



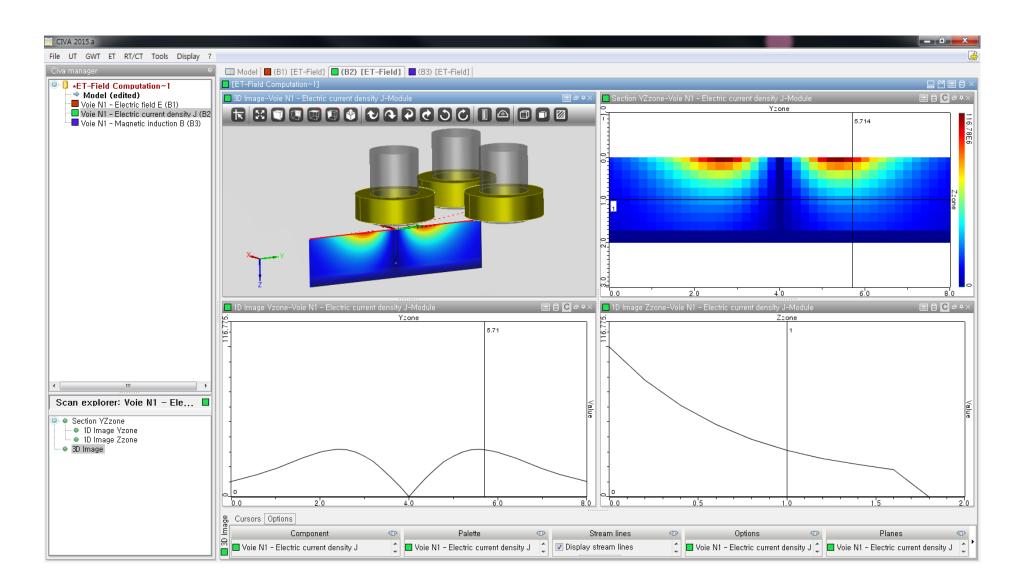








❖Result – Electric current density J

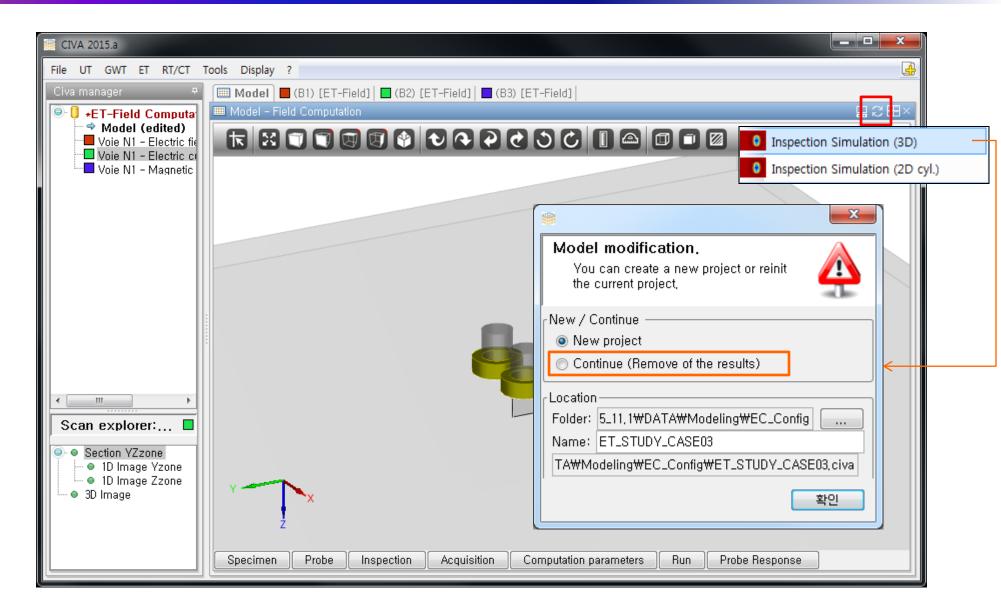




- Flat component inspection
- 1.3 Inspection Simulation with a calibration hole



❖Inspection Simulation(3D)로 변경

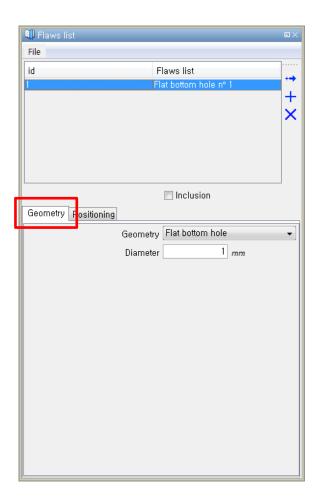


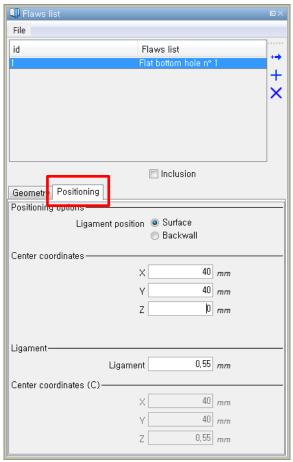






- 하단에 Flaws가 새로 생겨남



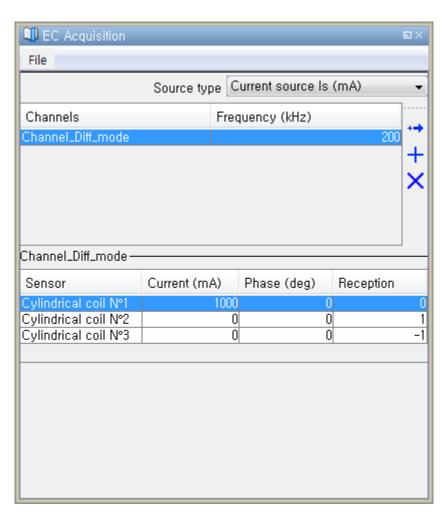




❖Acquisition 수정

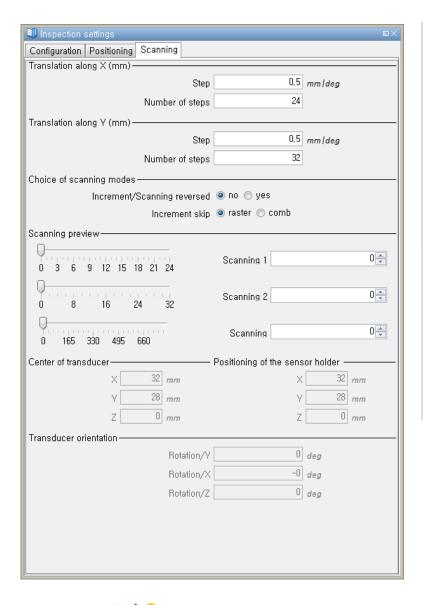


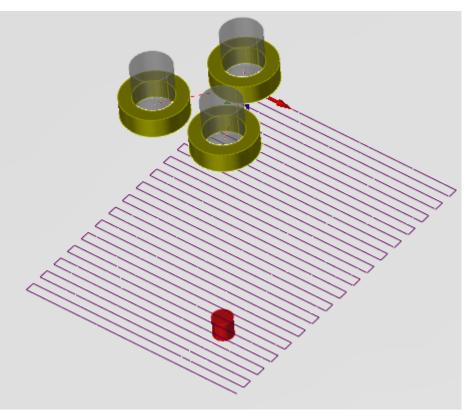
- 센서 변경(N1 - 송신부, N2, N3 - 수신부)





❖Inspection Settings 수정

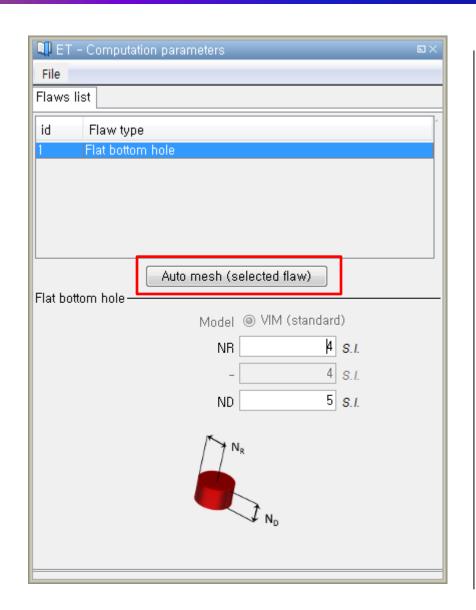




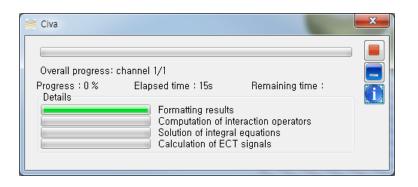


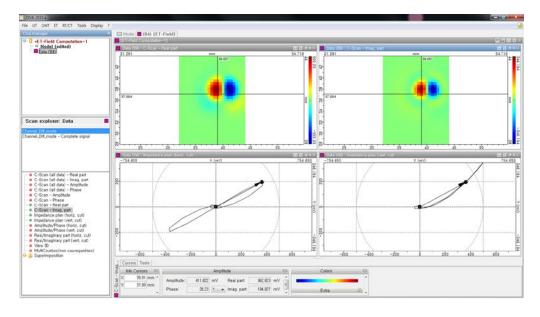
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❖Computation parameters 수정 및 Analysis



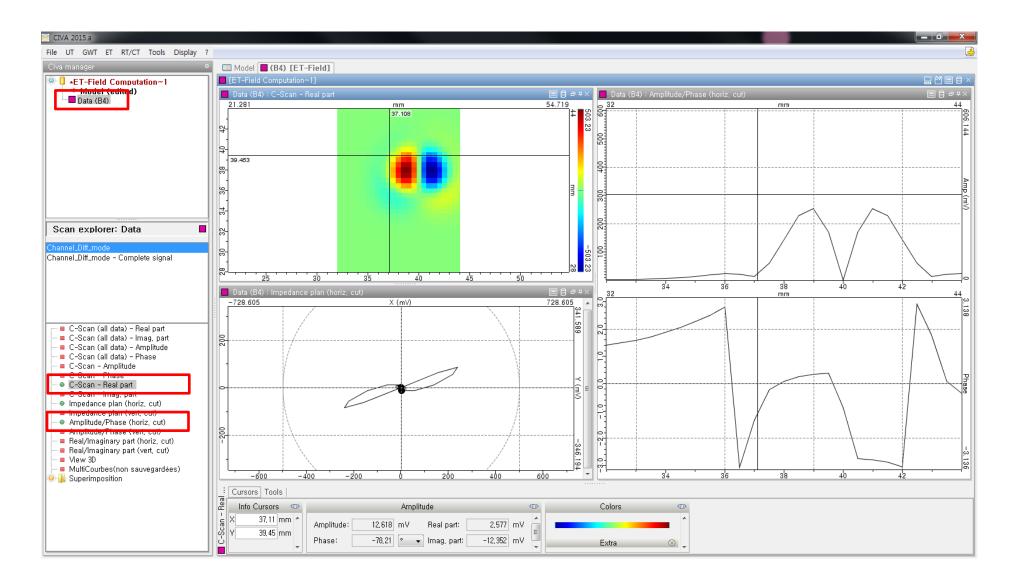














Thank You!

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